

ADM Papers

M. Schubert, C. Münch, S. Schuurman, V. Poulain, J. Kita, R. Moos:

Characterization of Nickel Manganite NTC thermistor films prepared by Aerosol Deposition at room temperature
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Functional Materials Letters, **10**, 1750073 (2017), doi: [10.1142/S1793604717500734](https://doi.org/10.1142/S1793604717500734)

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Compact Layers of Hybrid Halide Perovskites Fabricated via the Aerosol Deposition Process – Uncoupling Material Synthesis and Layer Formation
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J. Exner, M. Schubert, D. Hanft, T. Stöcker, P. Fuierer, R. Moos:

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Sensors and Actuators B: Chemical, **230**, 427-433 (2016), doi: [10.1016/j.snb.2016.02.033](https://doi.org/10.1016/j.snb.2016.02.033)

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